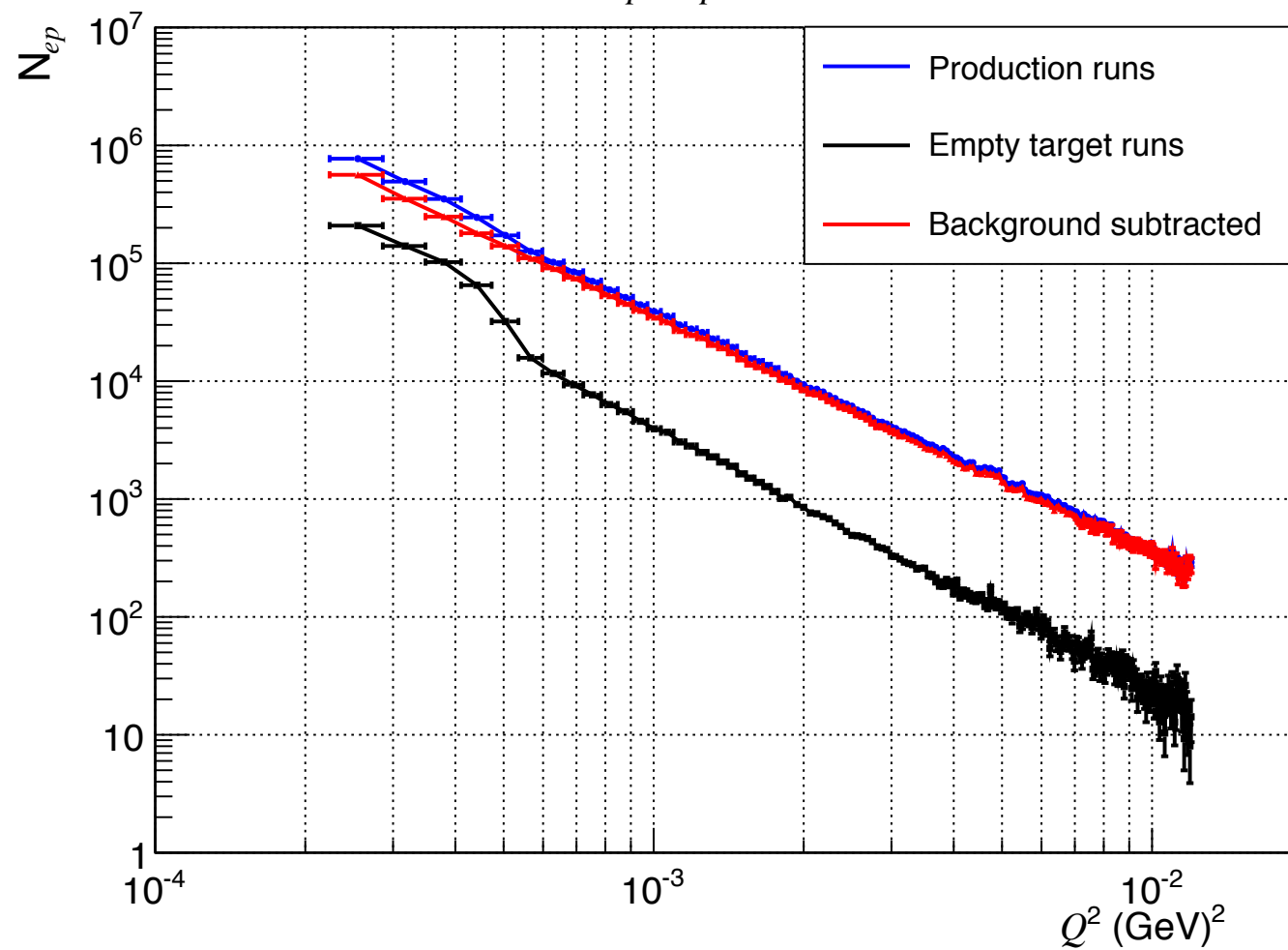


# Stability of ep to ee2 Ratio

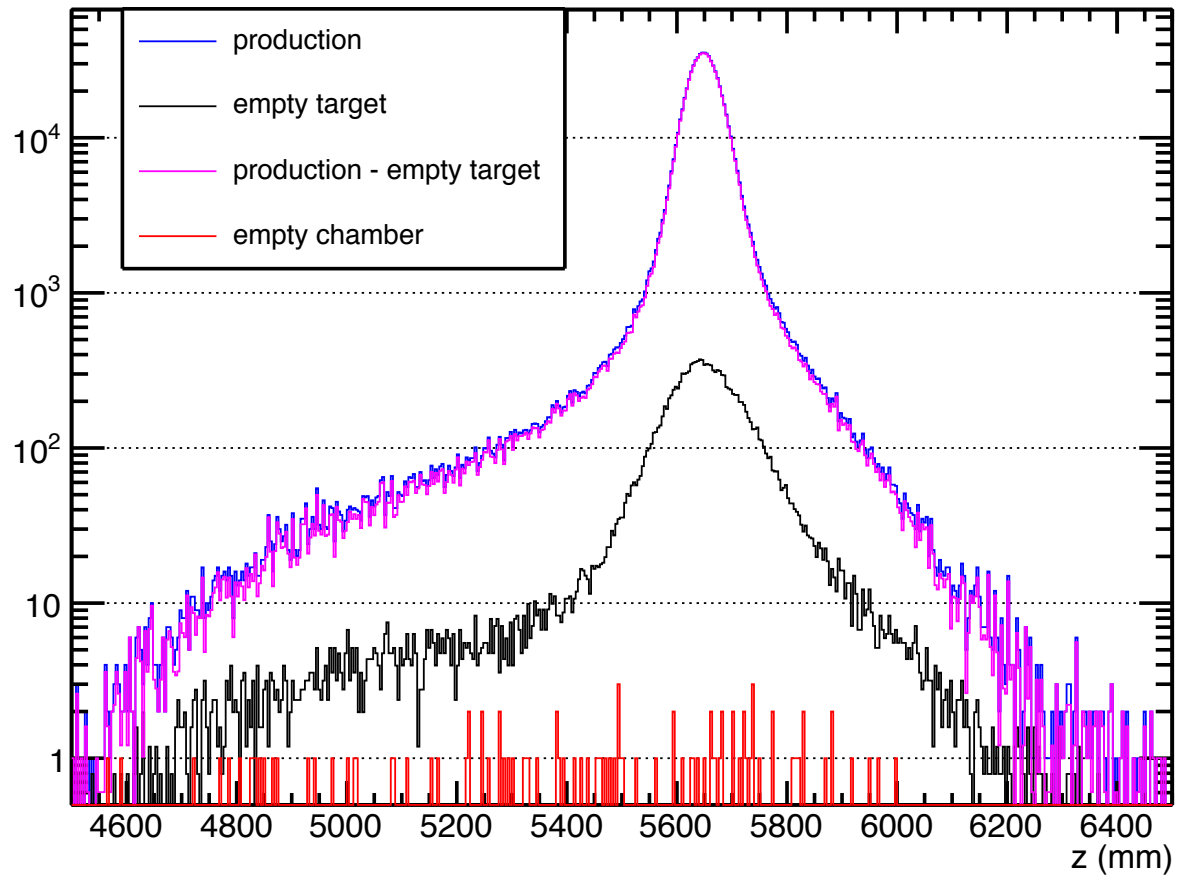
- For ep, background from residual gas and beam line contribute to at least **10%** of the yield (~30% at theta < 1.2 deg)
- For double arm Moller, the contribution is less than 2%
- The live charge weighted double arm Moller yield has a fluctuation of about +/-15%
- So if the background is not subtracted clean for ep, there will be a ~  
~<3% fluctuation in the ratio

# $N_{ep \rightarrow ep}$ vs. $Q^2$



# Distance between Projection Plane and Vertex Z

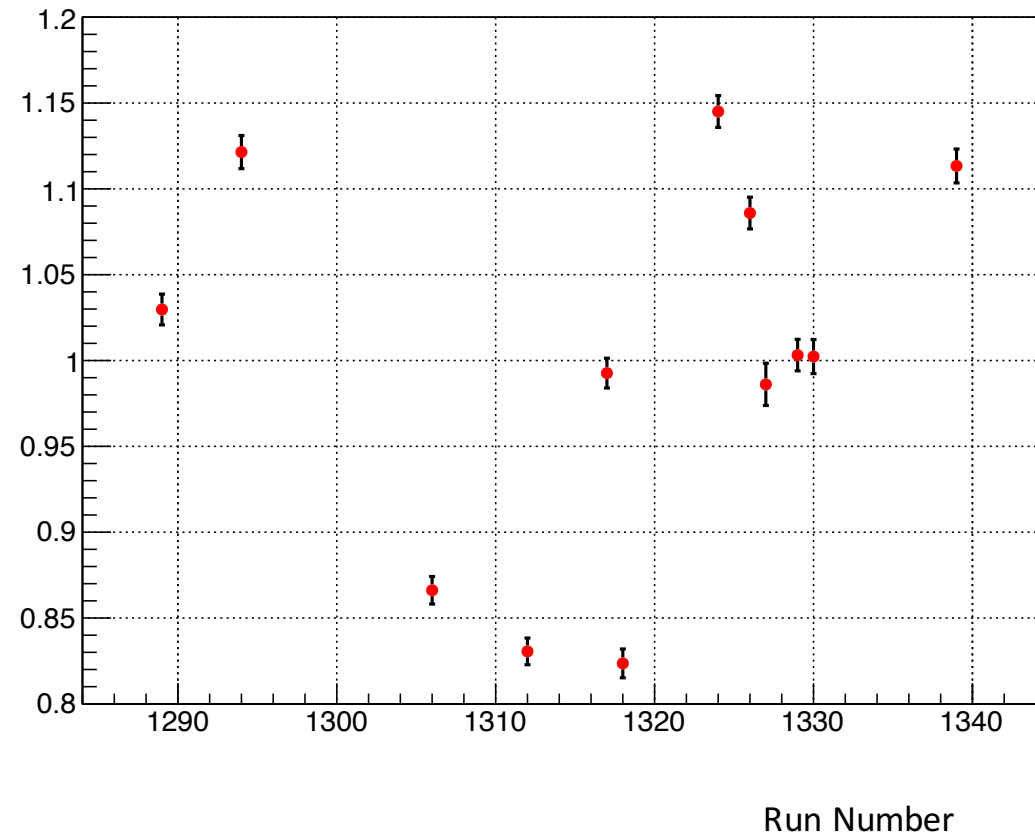
z\_hist



# Live charge weighed double arm Moller yield from empty target

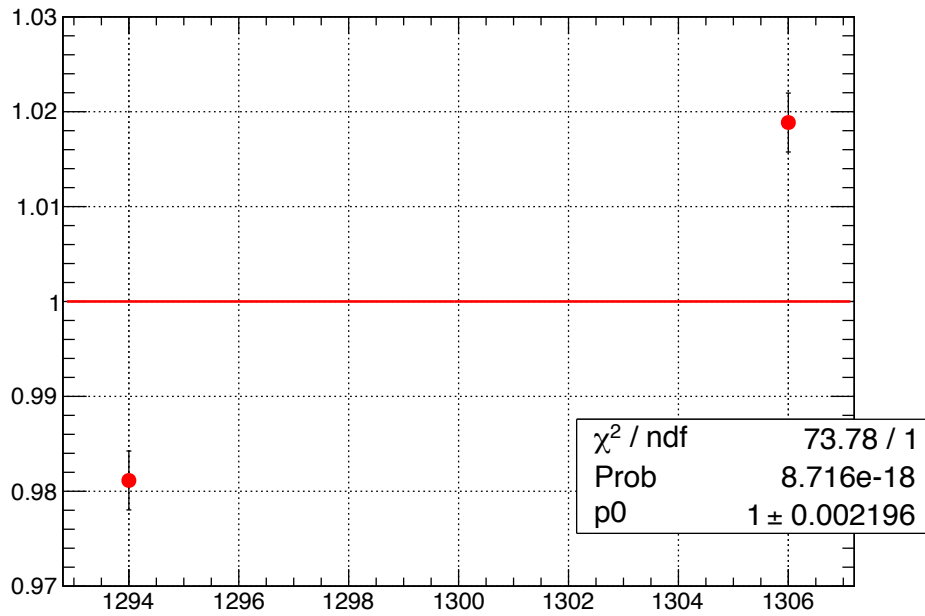
Graph

- Normalized and live charge weighed double arm Moller background from empty target run
- Each point is the integrated yield from 0.8 to 3.4 deg, normalized to be average value of all data points
- The two factors contribute to this fluctuation:
  - Live charge
  - Target thickness of residual gas
- Such large fluctuation is not observed in yield from neighboring production runs (0.98~1.04)

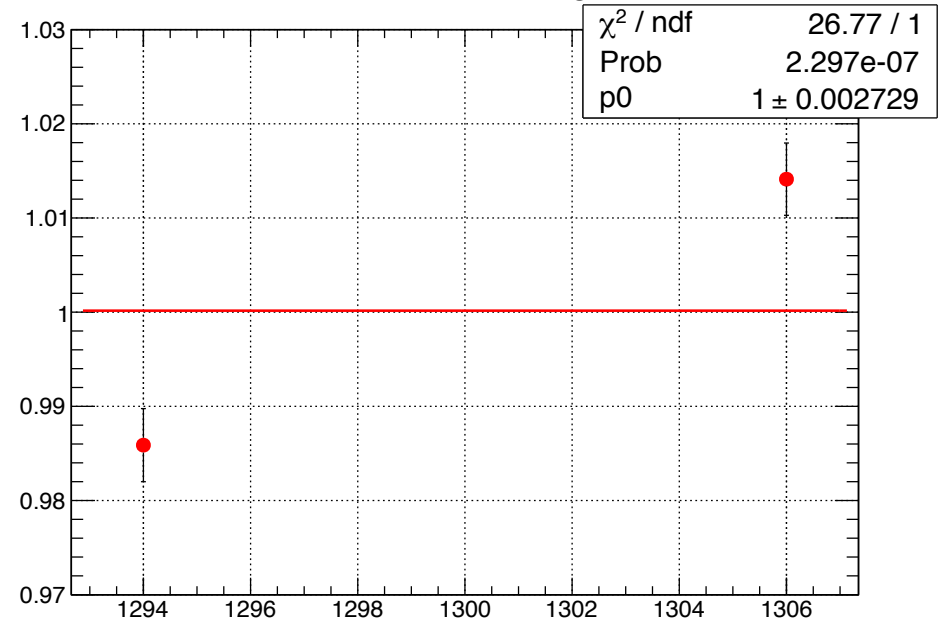


# Ratio of ep / ee2, after background subtraction using empty target run 1294 or 1306

ratio ( $\theta < 1.3$  deg)

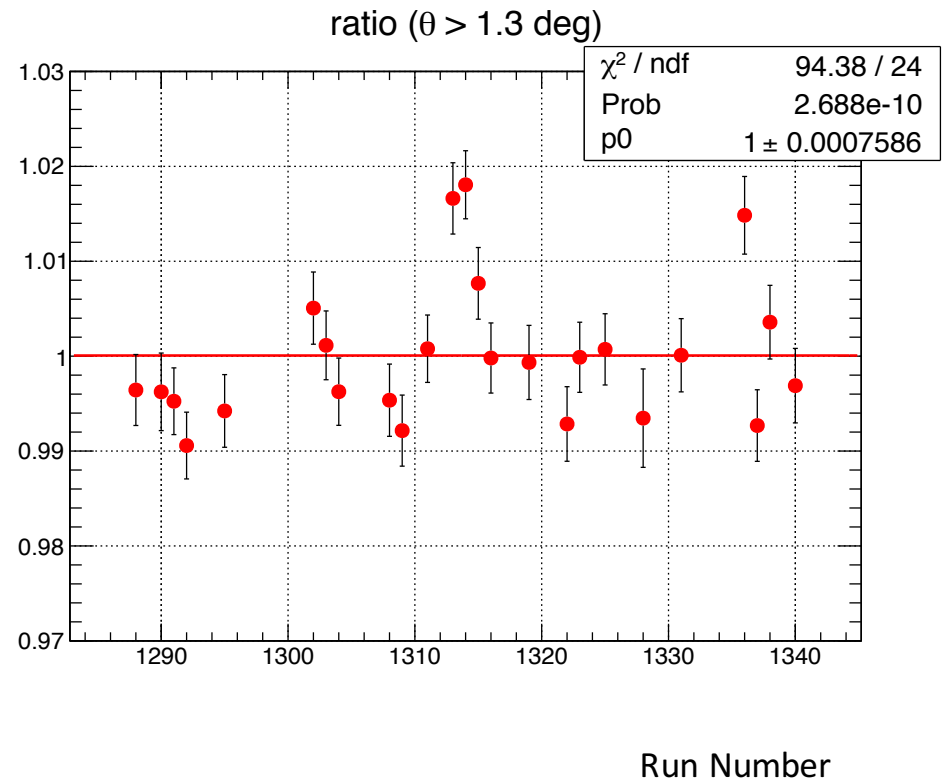
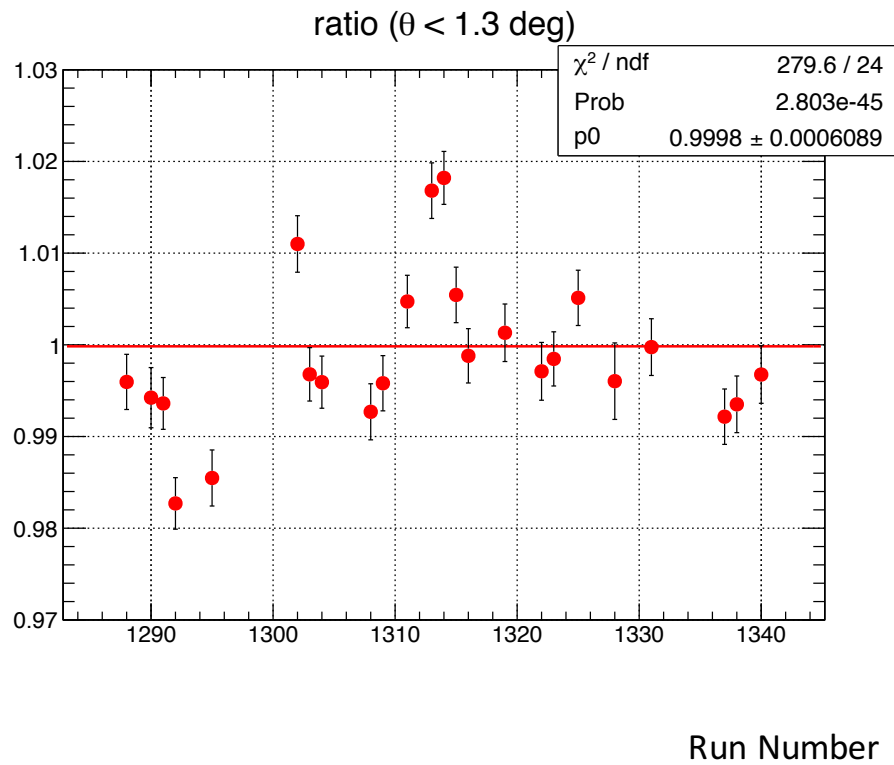


ratio ( $\theta > 1.3$  deg)



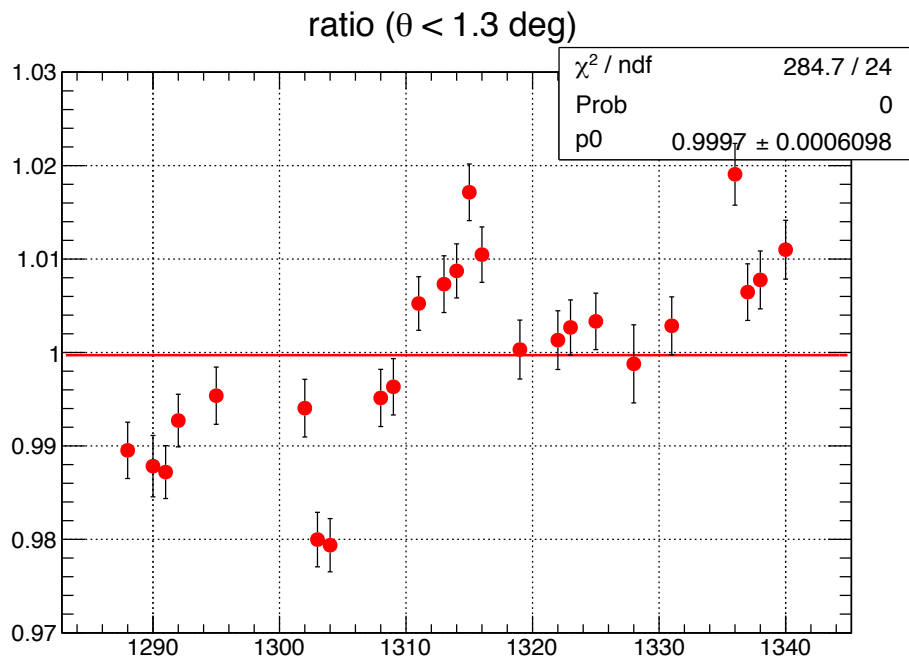
# Stability of ep to ee2 ratio

For each production run, using only the nearest empty target run

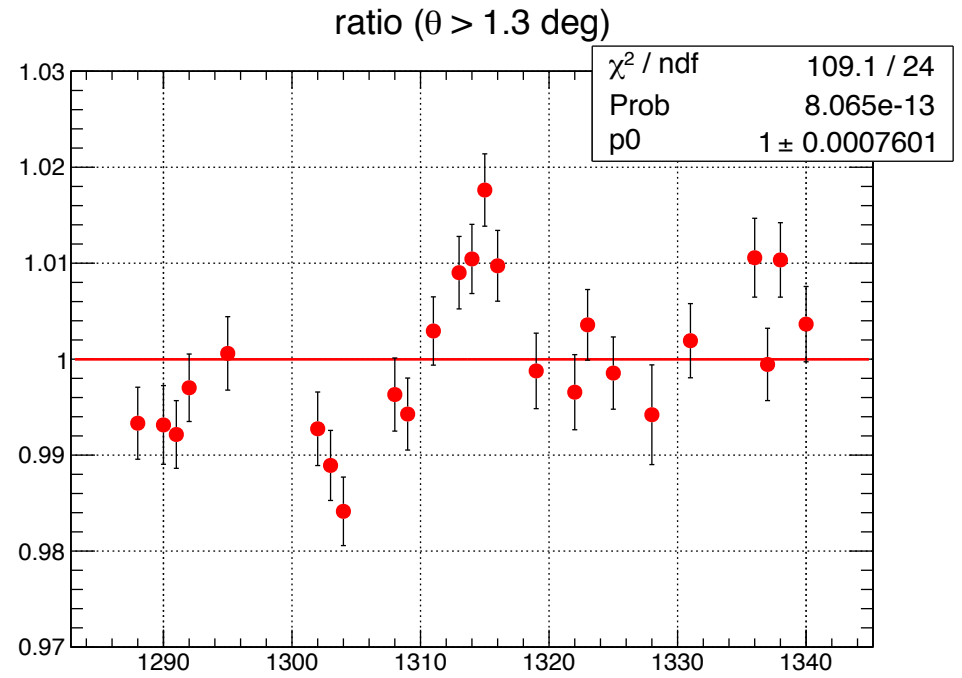


# Stability of ep to ee2 ratio

For each production run, using two nearest empty target run



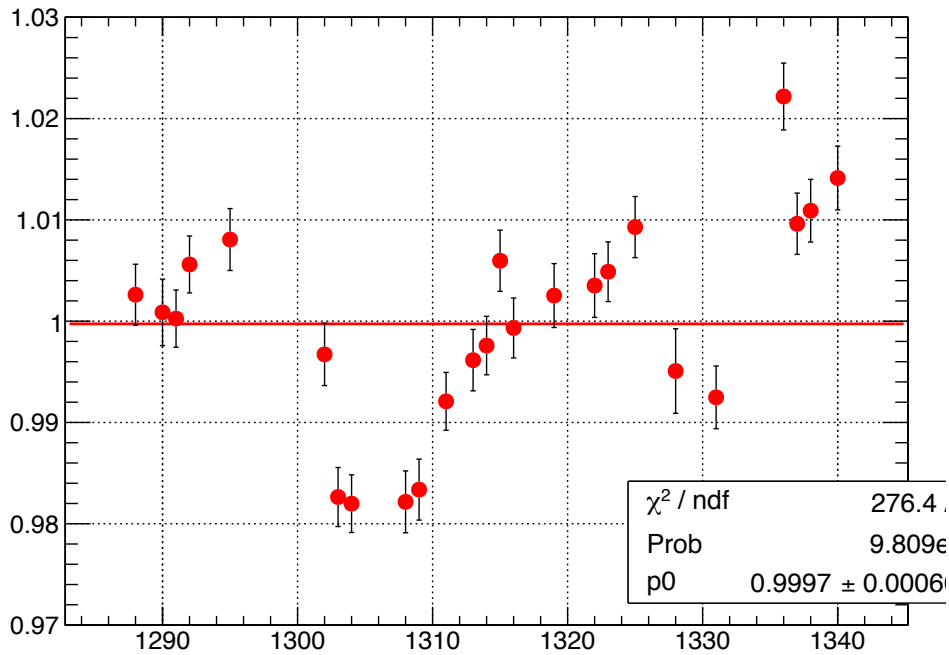
Run Number



Run Number

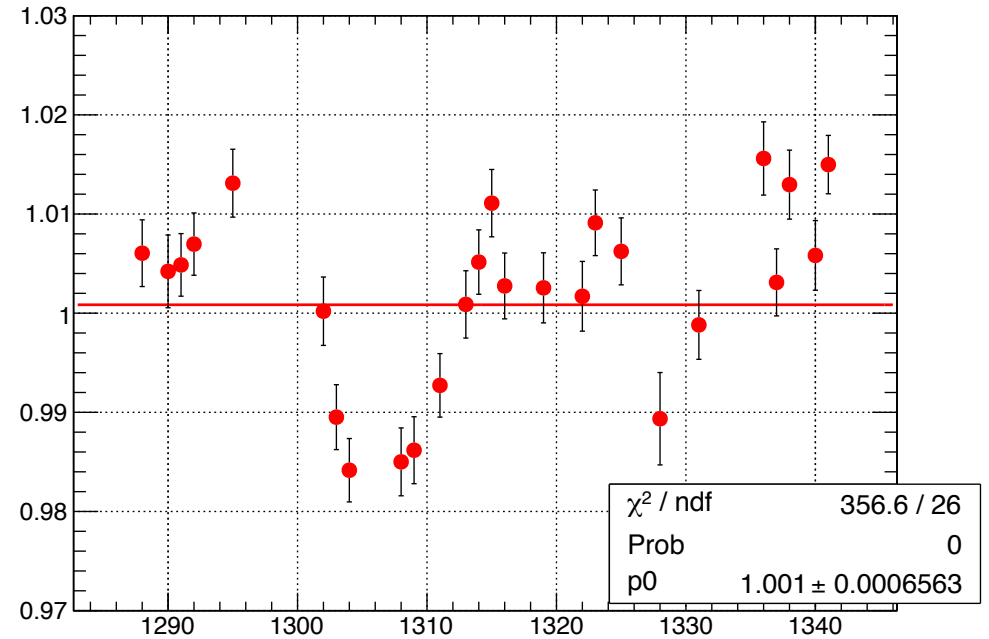
# Stability of ep to ee2 ratio

For each production run, using four nearest empty target run  
ratio ( $\theta < 1.3$  deg)



Run Number

ratio ( $\theta > 1.2$  deg)

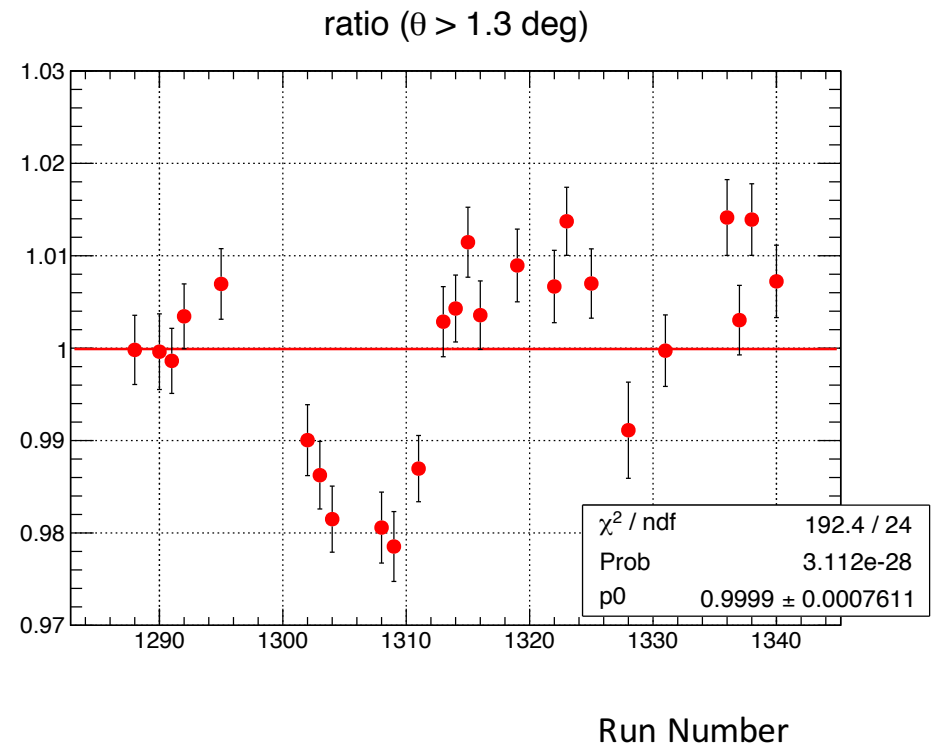
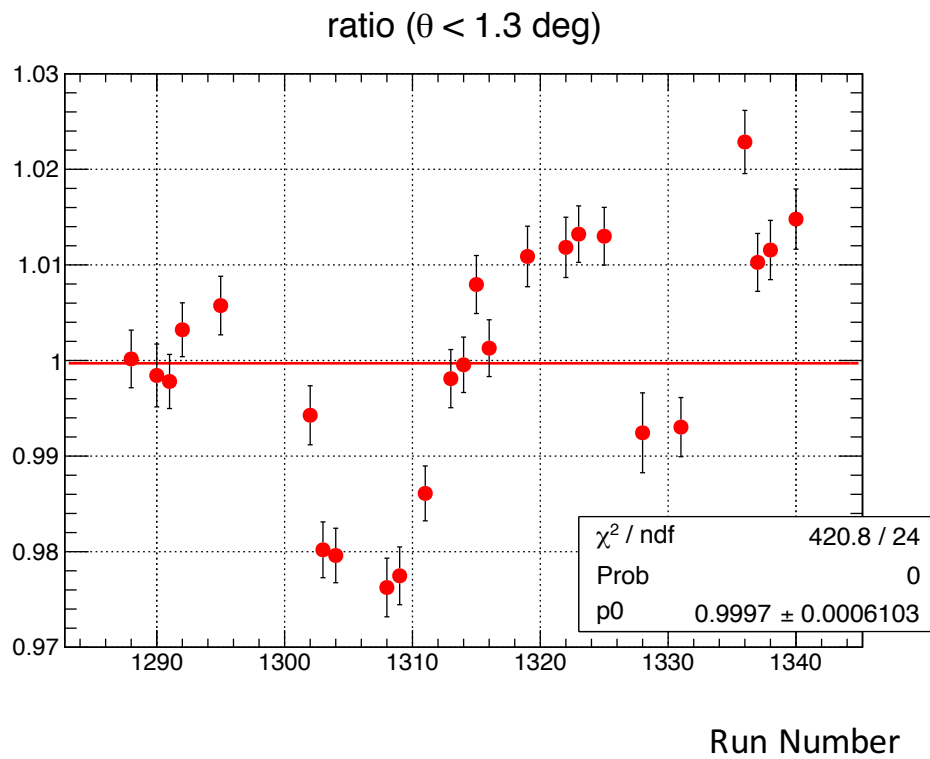


Run Number



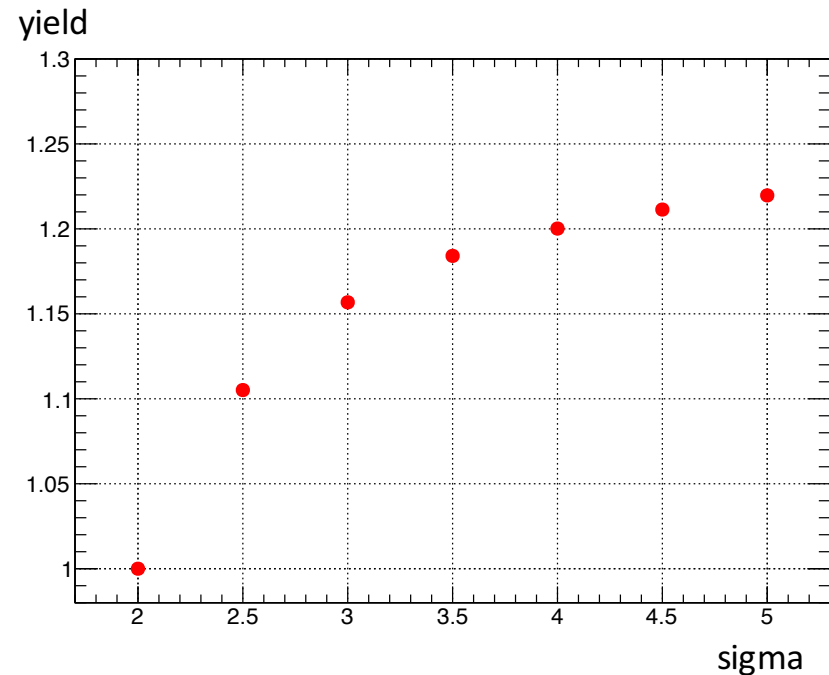
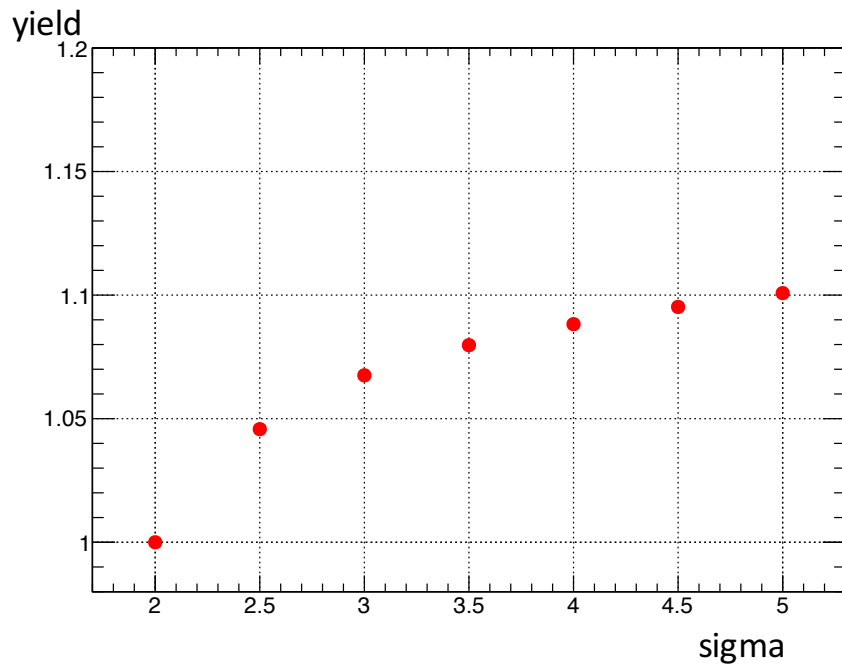
# Stability of ep to ee2 ratio

For each production run, using all empty target runs



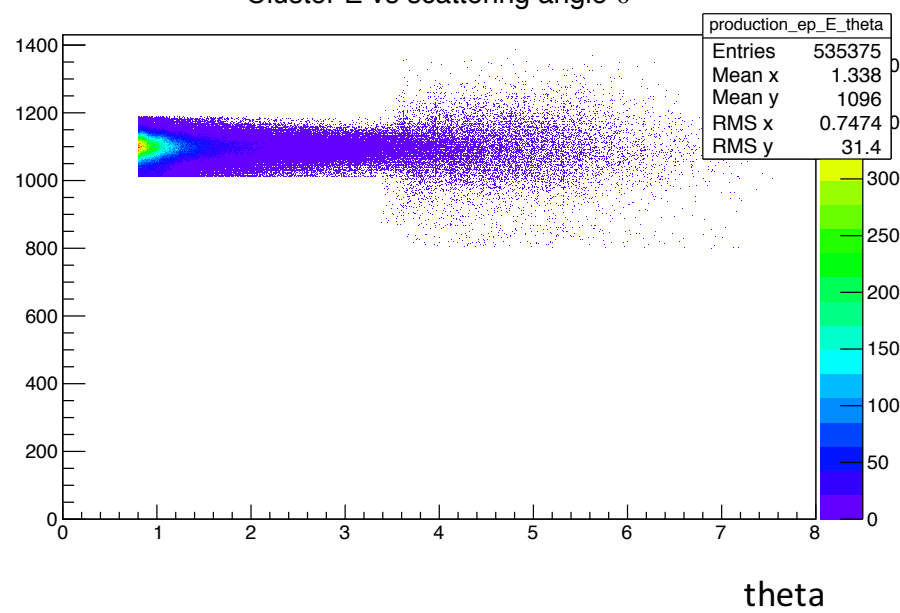
# Ep and ee2 yield sensitivity to cuts

- For run 1288, change the energy cut on ep and ee2, see how to yield varies
- For ep, simply just cut around the energy, for ee2, require each electron within certain sigma of the expected energy, and the sum agree with the beam energy within certain sigma
- Yield normalized to the one with sigma = 2



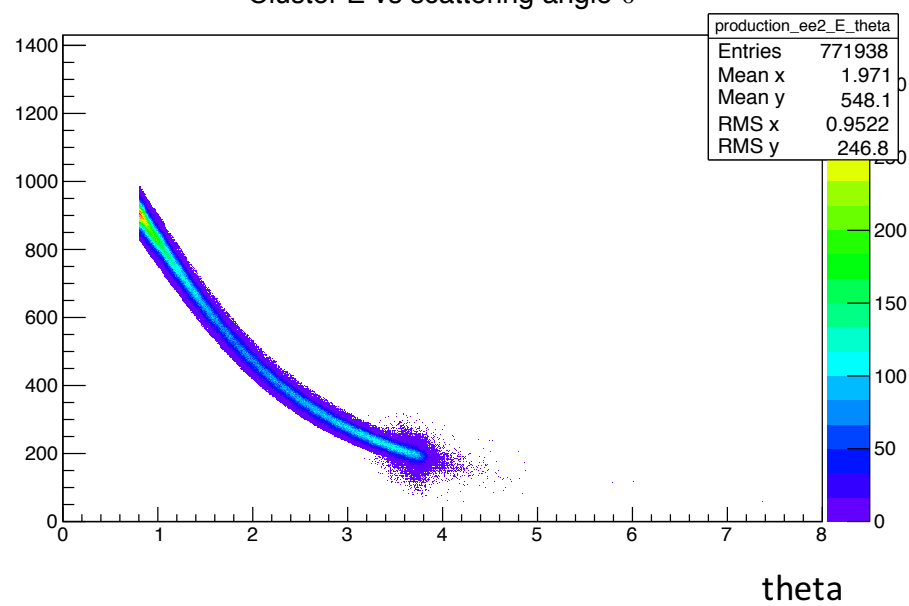
MeV

Cluster E vs scattering angle  $\theta$



MeV

Cluster E vs scattering angle  $\theta$



coplane

